

	Type	L #	Hits	Search Text	DBs
1	IS&R	L23	2	("6850133").PN.	US- PGPUB; USPAT; EPO; JPO; DERWEN T; IBM_TD B
2	BRS	L24	136120	(contact electrode) same(metal\$4 adj (layer contact film))	US- PGPUB; USPAT; EPO; JPO; DERWEN T; IBM_TD B
3	BRS	L25	1626	(microelectromechanical or micro-electromechanical or micro-electro-mechanical or mems or microactuator) and beam and L24	US- PGPUB; USPAT; EPO; JPO; DERWEN T; IBM_TD B
4	BRS	L26	949	335/78.ccls. 200/181.ccls.	US- PGPUB; USPAT; EPO; JPO; DERWEN T; IBM_TD B

	Type	L #	Hits	Search Text	DBs
5	BRS	L28	78	25 and 26	US- PGPUB; USPAT; EPO; JPO; DERWEN T; IBM_TD B
6	BRS	L29	48	electorde with signal	US- PGPUB; USPAT; EPO; JPO; DERWEN T; IBM_TD B
7	BRS	L30	0	electorde with actuation	US- PGPUB; USPAT; EPO; JPO; DERWEN T; IBM_TD B
8	BRS	L31	0	(microelectromechanical or micro-electromechanical or micro-electro-mechanical or mems or microactuator) and 29 and 30	US- PGPUB; USPAT; EPO; JPO; DERWEN T; IBM_TD B

	Type	L #	Hits	Search Text	DBs
9	BRS	L32	3674	electrode with actuation	US- PGPUB; USPAT; EPO; JPO; DERWEN T; IBM_TD B
10	BRS	L33	162743	electrode with signal	US- PGPUB; USPAT; EPO; JPO; DERWEN T; IBM_TD B
11	BRS	L34	1323	32 and (29 33)	US- PGPUB; USPAT; EPO; JPO; DERWEN T; IBM_TD B
12	BRS	L35	325	(microelectromechanical or micro-electromechanical or micro-electro-mechanical or mems or microactuator) and 34	US- PGPUB; USPAT; EPO; JPO; DERWEN T; IBM_TD B
13	BRS	L36	13	(capped and metallic and contact).clm.	US- PGPUB

	Type	L #	Hits	Search Text	DBs
14	BRS	L37	5045	(microelectromechanical or micro-electromechanical or micro-electro-mechanical or mems or microactuator).clm.	US-PGPUB; USPAT; EPO; JPO; DERWEN T; IBM_TDB
15	BRS	L38	1	36 and 37	US-PGPUB; USPAT; EPO; JPO; DERWEN T; IBM_TDB
16	BRS	L39	7566	(electrode with signal).clm.	US-PGPUB
17	BRS	L40	153	(electrode with actuation).clm.	US-PGPUB
18	BRS	L41	34	39 and 40	US-PGPUB
19	BRS	L42	14	37 and 41	US-PGPUB
20	BRS	L43	34697	cavity.clm.	US-PGPUB
21	BRS	L44	1	37 and 39 and 40 and 43	US-PGPUB